




PATENT

I hereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Commissioner for Patents, Washington, DC 20231.

December 31, 2001

Date


Rena Iov

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Present Application

Applicants : Chee Peng Neo, Cher Khng Victor Tan, Kian Seng Ho and Hock Chuan Tan

Application No. : 09/944,247 Confirmation No.: 1800

Filed : August 30, 2001

For : METHOD AND APPARATUS FOR DETECTING TOPOGRAPHICAL FEATURES OF MICROELECTRONIC SUBSTRATES

Docket No. : 108298548US

Date : December 31, 2001

Foreign Application

Application No. : 200104881-8

Country : Singapore

Filed : August 13, 2001

Commissioner for Patents
Washington, DC 20231

PRELIMINARY AMENDMENT

Dear Commissioner:

Please amend the application as follows and consider the application in light of the following remarks.